

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Hidemasa KAI**

Art Unit: **1792**

Application Number: **10/626,675**

Examiner: **Ram N. Kackar**

Filed: **July 25, 2003**

Confirmation Number: **1831**

For: **EPITAXIAL WAFER PRODUCTION APPARATUS AND SUSCEPTOR STRUCTURE**

Attorney Docket Number: **030901**  
Customer Number: **38834**

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

November 10, 2008

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated June 12, 2008 for two months from September 12, 2008 to November 12, 2008 (a one month extension of time was paid on September 30, 2008).

Attached please find our payment in the amount of \$370.00 for the cost of the extension of time. If any additional fees are due in connection with this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

**WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP**



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